INFORMATION DISCLOSUME STATEMENT (37 C.F.R. 1.56, 1.97, and 1.98)				EMENT	ATTORNEY DOCKET NO: 26767-1000	APPLICATION NO: 09/375,169	
					APPLICANTS: C. Aita et al.		
		SHEET 1 OF	÷ 7		FILING DATE: August 16, 1999	GROUP: 1775	
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Shu	AB	5,496,359	03/05/96		Davidson	-607/115	08/26/93
×1/~	AC	5,676,632	10/14/97		Davidson	600/16	06/06/95
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INFORMATION DISCLOSURE STATEMENT				26767-1000	APPLICATION NO: 09/375,169	
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INFORMATION DECLOSURE STATEMENT (37 C.F.R. 1.56, T.97, and 1.98) ATTORNEY DOCKET NO: 26767-1000 APPLICATION NO: 09/375769							
	APPLICANTS: C. Aita et al.						
SHEET 3 OF 7			FILING DATE: August 16, 1999	GROUP: 0775			
		OTHER DO	CUMENTS				
† EX'R INITIAL	* REF. #	CITATION (Author, Article Tit	tle, Journal/Book Title, Date, Pertinent P	ages, etc.)			
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INFORMATION DISCLOSURE STATEMENT

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INFORMATION DISCLOSURE STATEMENT (37 C.F.R. 1.56, 1.97, and 1.98)			ATTORNEY DOCKET NO: 26767-1000	APPLICATION NO: 09/375759 17 00 PR		
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